

Research and Development Section Indian Institute of Technology Guwahati Guwahati-781039, Assam

Applications are invited for **Walk-in-interview** of the following post(s) for **Contractual recruitment** in the project entitled, "**SWASTHA - Smart Wearable Advanced Nano Sensing Technologies in Healthcare ASICs**" at Centre for Nanotechnology, **IIT Guwahati.**

Date: 9th July 2024 (Tuesday) Time: 10:30 AM Venue: Conference Room, Centre for Nanotechnology, IIT Guwahati Reporting Time: 9:30 AM

Sl. No	Designatio n	ies	Recomme nded (Rs.)		Medical Require d (Rs.)	Amount (Rs.)	Duratio n of Appoin tment in month s	Qualifications
1	SRF (DIRECT)	08	35,000.00	6,300.00	1250.00	42,550.00	03	 Post Graduate in Basic Science or Graduate/Post Graduate in Professional Course selected through a process described through any one of the following: 1. Scholars selected through National Eligibility Test- CSIRUGC NET including Lectureship (Assistant Professorship) and GATE. 2. The selection process through National Level examinations conducted by Central Government Departments and their Agencies and institutions such as DST, DBT, DAE, DOs, DRDO, MHRD, ICAR, ICMR, IISC, IISCR etc.+2 yrs of research Exp. Preferable requirements: Expertise in NanoScience, Nanotechnology, Nanobiology, Nanoelectronics and hands-on experience in Nano-fabrication and characterization (such as AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micro-machining, Wire Bonding, Double Sided Mask Aligner, Thermal/E–Beam

								Evaporation, RF Magnetron Sputtering Unit, Oxidation/ Diffusion Furnaces Reactive Ion Etching, FESEM-EBL, Mask Writer, Raman, IR, Cryogenic DC Probe Station and Pulse parametric Analyzer)
2	Project Scientist	02	47,000.00	8,460.00	1,250.00	56,710.00	11	 PhD degree Or Master's degree in Science + 6 yrs exp. Desirable experience: Expertise in NanoScience, Nanotechnology, Nanobiology, Nanoelectronics and hands-on experience in Nano-fabrication and characterization (such as AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micro-machining, Wire Bonding, Double Sided Mask Aligner, Thermal/E–Beam Evaporation, RF Magnetron Sputtering Unit, Oxidation/Diffusion Furnaces Reactive Ion Etching, FESEM-EBL, Mask Writer, Raman, IR, Cryogenic DC Probe Station and Pulse parametric Analyzer) Administration and general implementation of the project along with Report writing, operation & Characterization facilities, Health-Care, Energy and POCT devices
3	Associate Project Scientist	01	35,000.00	6,300.00	1,250.00	42,550.00	11	 Master`s degree in Science Or Bachelor`s degree in Science + 4 yrs exp. Desirable experience: Expertise in NanoScience, Nanotechnology, Nanobiology, Nanoelectronics and hands-on experience in Nano-fabrication and characterization (such as AFM, SEM, TEM, XRD, Electro-Spinning Device,

		01	25 000 00					Materials Printing System, Laser Micro-machining, Wire Bonding, Double Sided Mask Aligner, Thermal/E–Beam Evaporation, RF Magnetron Sputtering Unit, Oxidation/ Diffusion Furnaces Reactive Ion Etching, FESEM-EBL, Mask Writer, Raman, IR, Cryogenic DC Probe Station and Pulse parametric Analyzer) General implementation of the project along with report writing, operation and maintenance of High end micro/nano fabrication & Characterization facilities, Health-Care, Energy and POCT devices
4	Associate Project Engineer	01	35,000.00	6,300.00	1,250.00	42,550.00	11	 Master's degree Engineering or Bachelor's degree in Engineering + 3 yrs exp. Desirable experience: Expertise in NanoScience, Nanotechnology, Nanobiology, Nanoelectronics and hands-on experience in Nano-fabrication and characterization (such as AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micro-machining, Wire Bonding, Double Sided Mask Aligner, Thermal/E–Beam Evaporation, RF Magnetron Sputtering Unit, Oxidation/ Diffusion Furnaces Reactive Ion Etching, FESEM-EBL, Mask Writer, Raman, IR, Cryogenic DC Probe Station and Pulse parametric Analyzer) General implementation of the project along with report writing, operation and maintenance of High end micro/nano fabrication & Characterization facilities, Health-Care, Energy and POCT devices

	01	7,450.00	1,341.00	1,250.00	10,041.00	11	High School pass with 1 yr exp.
Attendant							Desirable experience:
							• Basic fundamental knowledge
							of lab maintenance.
							• Movement of Files, Lab
							Cleaning, Electrical and Lab
							Maintenance and other related
							activities.

How to apply and selection process: Candidates have to appear in the Walk in Interview along with an application/CV on plain paper giving details of all educational qualifications, experience, contact address, phone no., E- mail etc. and submit photocopies of relevant documents at the time of interview on 9th July 2024 (Tuesday) at 09:30 am. Venue: Centre for Nanotechnology.

Selection will be based on the performance of the candidate in the interview. Candidates will not be sent any call letter separately. Advance copy of CV may be sent to the Principal Investigator. **For any clarification, contact**: Nano Office, Centre for Nanotechnology, IIT Guwahati **Email:** nano_off@iitg.ac.in **Phone:** 03612583066/3075

No campus accommodation will be available for the selected candidates.

No TA/DA will be paid to the candidates for appearing in the test and interview.

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Assistant Registrar(R&D)